



Atty. Dkt. No 025311-0105

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Ichiro OKABE et al.

Title: METHOD OF FORMING A FINE
PATTERN, AND METHOD OF
MANUFACTURING A
SEMICONDUCTOR DEVICE, AND
A SEMICONDUCTOR DEVICE
HAVING A FINE PATTERN

Appl. No.: 09/597,161

Filing Date: 06/20/2000

Examiner: Jose R. Diaz

Art Unit: 2815

#14/EX
10/22/02
Sunder
RECEIVED
OCT 18 2002
TECHNOLOGY CENTER 2800

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
Washington, D.C. 20231

Sir:

Applicants hereby petition the Commissioner under 37 C.F.R. §1.136(a) for a one-month extension of time for response in the above-identified application for the period required to make the attached response timely.

The extension fee for response within the first month is \$110.00. A check for this amount is enclosed herewith.

The Commissioner is hereby authorized to charge any additional fees which may be required regarding this application under 37 C.F.R. §§ 1.16-1.17, or credit any overpayment, to Deposit Account No. 19-0741. Should no proper payment be enclosed herewith, as by a check being in the wrong amount, unsigned, post-dated, otherwise improper or informal or even entirely missing, the Commissioner is authorized to charge the unpaid amount to Deposit Account No. 19-0741.

10/17/2002 BABRAHA1 00000022 09597161

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110.00 OP

Date October 15, 2002

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Respectfully submitted,

By

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